

IFW



**PATENT APPLICATION**

**THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q77321

Hiroshi OKUMURA

Appln. No.: 10/773,333

Group Art Unit: 3663

Confirmation No.: 8920

Examiner: Johannes P. MONDT

Filed: February 9, 2004

For: THIN FILM TRANSISTOR SUBSTRATE AND METHOD OF MANUFACTURING  
THE SAME

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 26, 2006, please amend the above-identified application as follows on the accompanying pages.

**TABLE OF CONTENTS**

AMENDMENTS TO THE CLAIMS.....	2
REMARKS.....	8